

<b>Form 1449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)	Atty. Docket No.	Application No.:
	HIT1P009/ SJ0920020044US1	<del>Unassigned</del> 10/796,163
	Applicant: F. Dill et al.	
	Filing Date: Herewith	Group Art Unit: Unassigned

**U.S. Patent Documents**

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
WK	1	6,282,056	08/28/2001	Feng et al.	360	126	04/08/1999
WK	2	6,226,149	05/01/2001	Dill, Jr. et al.	360	126	12/15/1998
WK	3	6,198,600	03/06/2001	Kitao et al.	360	235.2	06/08/1999
WK	4	6,091,581	07/18/2000	Gray et al.	360	126	02/10/1997
WK	5	6,081,408	06/27/2000	Partee	360	113	12/02/1997
WK	6	6,073,338	06/13/2000	Liu et al.	29	603.14	08/19/1997
WK	7	5,784,224	07/21/1998	Rottmayer et al.	360	113	07/17/1996
WK	8	5,658,470	08/19/1997	Schultz et al.	216	22	12/13/1995
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WK	10	2002/0141111	10/03/2002	Batra et al.	360	125	03/15/2002
WK	11	2002/0080525	06/27/2002	Sato et al.	360	126	12/18/2001
WK	12	2002/0039254	04/04/2002	Taguchi et al.	360	125	09/14/2001
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**Foreign Patent or Published Foreign Patent Application**

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
WK	18	11273026	1999-10-08	JP	<del>G11B</del>	<del>5/31</del>		
	19							

**Other Documents**

Other Documents		
Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
WK	20	Hsiao, R., "Fabrication of Magnetic Recording Heads and Dry Etching of Head Materials," IBM Journal of Research and Development, Volume 43, 1/2, 1999
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Examiner /William Klimowicz/ (08/18/2006)		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.